

#### BWLF-R63 MMIC Low pass Filter

#### Feature

- High Precision GaAs process
- High performance, shielded
- •GaAs substrate, 50Ω CPW output
- Au wire bonding, for MCM applications

## **Environmental Specifications**

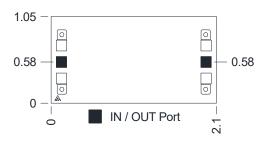
Operating Temperature	nperature -55°C~+85°C	
Storage Temperature	-65°C~+150°C	
Max. Input Power	30dBm	

## **Electrical Specifications**(T<sub>A</sub>=+25°C)

Parameter	Min.	Тур.	Max.	Unit
Cut-off Freq. (f₀)	-	0.63	-	GHz
Insertion Loss @ fc	-	-	1.5	dB
Return Loss	15	-	-	dB
Out of band	≥20@1.4GHz			dB
Attenuation	≥40@2.1GHz			dB

S2P file name: BWLF-R63.s2p

#### **Outline Drawing**



#### Notes:

1. Dimensions are in millimeters. Tolerance: ±0.05mm

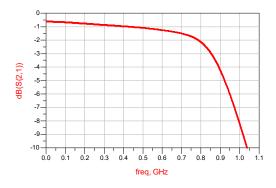
2. Die thickness is 0.1mm

3. Typical bond pad is 0.1x0.1 mm<sup>2</sup>.

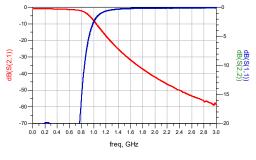
4. The bottom of the device is gold plated, should be grounded.

# **Typical Test Curves**

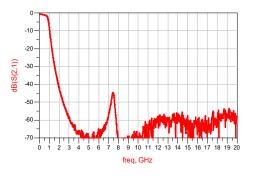
Insertion Loss VS Frequency (T<sub>A</sub>=25°C)



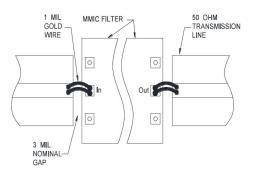
Insertion Loss & Return Loss VS Frequency  $(T_A=25^{\circ}C)$ 



Broadband Insertion Loss VS Frequency (T<sub>A</sub>=25°C)



## **Recommended Assembly Diagrams**



#### **Application Notes:**

1. The chip is back-metallized and can be die-mounted with AuSn eutectic preforms or with electrically conductive epoxy.

2. The die should be assembled on carriers like Kovar or Mu-Cu which have same Coefficient of thermal expansion. (5.8×10-6/ ) with GaAs.

3. Recommend using  $\Phi 25 \text{um}$  Au wire for bonding, whose length is around 400 \text{um}.

4. Sinter by AuSn (80/20), which doesn't exceed 300°C within 30 seconds max.

4. Handle the chips in a clean environment. DO NOT attempt to clean the chip using liquid cleaning systems.

5. Handle the chip along the edges with a vacuum collet or with a sharp pair of bent tweezers.

6. The device is sensitive to ESD. ESD protection is required during storage and usage.

7. If you have any questions, please contact us.